NOTES:

- 1. SUBSTRATE: UV FUSED SILICA
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
- 3. COATING (APPLY ACROSS COATING APERTURE)

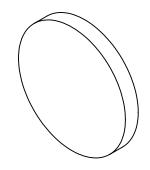
\$1: HARD DIELECTRIC \$PUTTERED T(avg): ≥91% FROM 560 - 1650nm @ 0° AOI T(avg): ≤0.01% FROM 200 - 539nm @ 0° AOI T(abs): =50% FOR 550±5.5nm @ 0° AOI

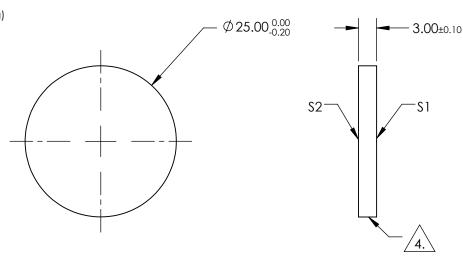
S2:SINGLE LAYER MgF2

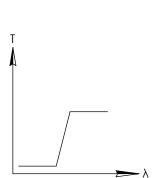
4. FINE GRIND SURFACE

- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm (prior to coating)
- 7. ROHS COMPLIANT









LONGPASS FILTER

	\$1	\$2	
SHAPE	PLANO	PLANO 60-40	
SURFACE QUALITY	60-40		
CLEAR APERTURE	>80%	>80%	
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED	

SPECIFICATIONS SUBJECT TO CHANGE WITHOUT NOTICE DIMENSIONS ARE FOR REFERENCE ONLY

THIRD ANGLE PROJECTION		TITLE	Ø25mm, 550nm, HIGH PERFORMANCE LONGPASS FILTER	
ALL DIMS IN	mm	DWG NO	62984	SHEET 1 OF 1